



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Confirmation No.: 4153

OHMI et al.

Group Art Unit: 1763

Appln. No.: 09/827,307

Examiner: L. Alejandro Mulero

Filed: April 6, 2001

Title: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD

November 18, 2003

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AMENDMENT

RECEIVED

Hon. Commissioner of Patents
Washington, D.C. 20231

NOV 25 2003

TC 1700

Sir:

In response to the Office Action mailed August 13, 2003, please amend the above identified application as follows:

11/20/2003 CHNGUYEN 00000120 033975 09827307

01 FC:1251 110.00 DA